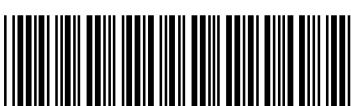


Search Notes	Application/Control No.	Applicant(s)/Patent Under Reexamination
	10720056	CHA, KI CHUL
	Examiner	Art Unit
	JASON HECKERT	1792

SEARCHED

Class	Subclass	Date	Examiner

SEARCH NOTES

Search Notes	Date	Examiner
Updated Search	1/29/2008	JMH
Updated Search	11/17/2008	JMH

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner

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